## Notice of References Cited Application/Control No. | Applicant(s)/Patent Under Reexamination | GONZALEZ ET AL. | Examiner | Art Unit | Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-			
	В	US-			
	С	US-			
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	1	US-			
	J	US-			
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## FOREIGN PATENT DOCUMENTS

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	N					
	0					
	Р					
	Q					
	R					
	s					
	Т					

## NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Wolf et al., "Silicon Processing for the VLSI Era, Volume 3: The Submicron MOSFET," Lattice Press, copyright 1995, Pp. 232-240, 309-311.			
	v				
	w				
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.